

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Confirmation No.: 6768
Hongyong Zhang)
Serial No. 09/633,869) Examiner: Alexander G. Ghyka
Filed: August 7, 2000) Group Art Unit: 2812
For: METHOD FOR LASER- PROCESSING SEMICONDUCTOR DEVICE) Date: August 1, 2008
)

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

An Information Disclosure Statement with Form PTO-1449 was filed in the above-identified patent application on August 5, 2004. Applicants have not yet received back from the Examiner, a copy of the Form PTO-1449 initialed to acknowledge the fact that the Examiner has considered the cited disclosed information. A copy of the Information Disclosure Statement, PTO-1449 Form, and post-card in question are attached hereto.

The Examiner is requested to initial and return to the undersigned a copy of the subject Forms PTO-1449.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,

/Jeffrey L. Costellia, Reg.#35483/
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This will acknowledge receipt of the following:

1. Information Disclosure Statement
2. PTO Form-1449
3. Seven (7) References

In re Patent Application of:

Inventor: Hongyong ZHANG et al.

Serial No.: 09/633,869

Filed: August 7, 2000

Title: METHOD FOR LASER-PROCESSING SEMICONDUCTOR DEVICE

Due Date: None

Docket No. 740756-2100

8683-JLC/kw

Date: August 5, 2004

**HAND CARRY
PLEASE DATE STAMP AND RETURN**

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